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Institut d'Optique



Diode-pumped Vertical-External-Cavity Surface-Emitting Laser (VECSEL) for atomic inertial sensors

B. Cocquelin, G. Lucas-Leclin and P. Georges

Laboratoire Charles Fabry de l'Institut d'Optique,
Orsay, France

I. Sagnes

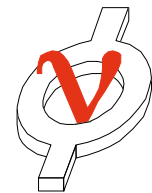
Laboratoire de Photonique et de Nanostructures,
Marcoussis, France

A. Garnache

Centre d'Électronique et de Micro Optoélectronique,
Montpellier, France



Equipe Lasers Solides
et Applications

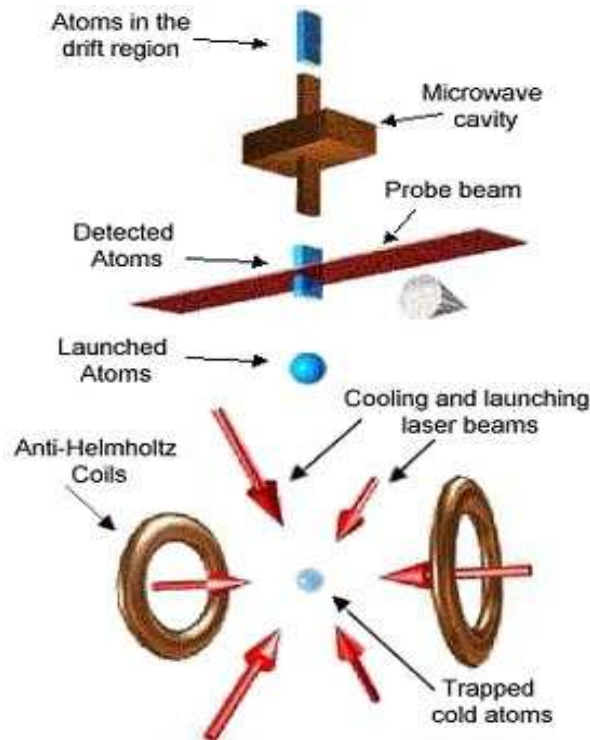


Outline

- **Laser diodes in inertial atomic sensors**
- **Principle of VECSEL's**
- **Our technological choices**
- **Experimental setup and results**
- **Prospects**

Laser diodes in inertial sensors

- Inertial sensors = Atomic clocks, gyrometers ...



Scheme of an atomic clock (Cs $\lambda=852$ nm)

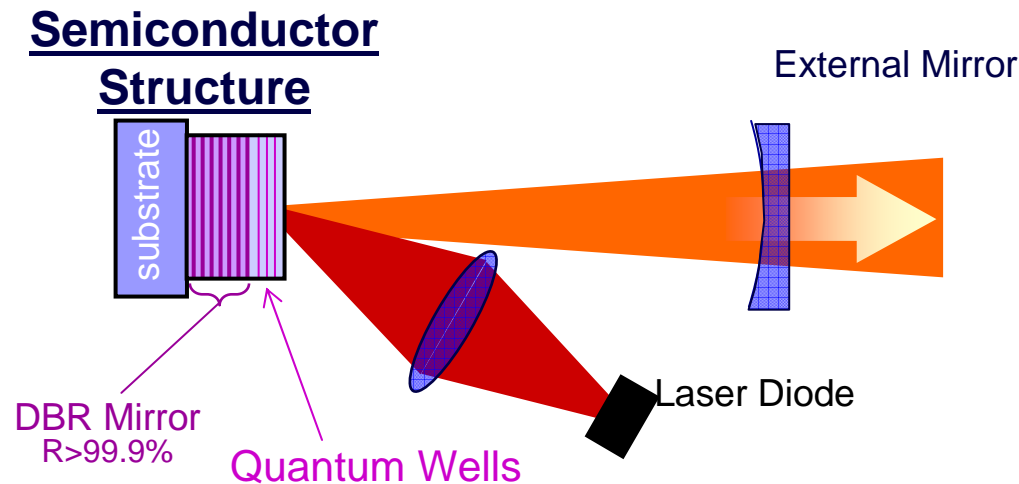
- Atom cooling : $P > 200$ mW
- Launch
- Atom preparation (Pumping)
- Microwave interrogation
- Detection : $\Delta\nu < 500$ kHz

**High power and narrow linewidth sources ?
To achieve more compact and simple optical benches**

Diode-Pumped VECSEL

VECSEL = Vertical-External-Cavity Surface-Emitting Laser

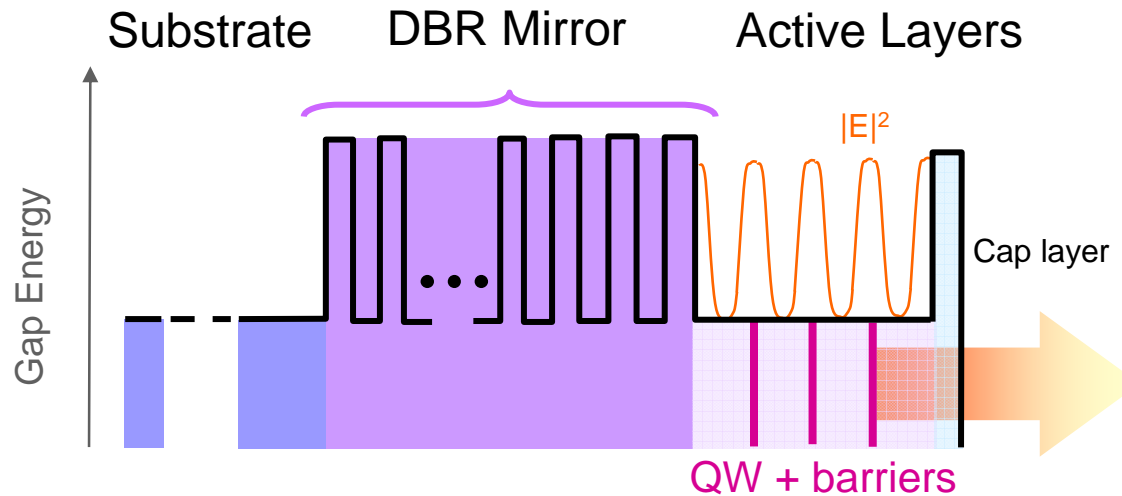
Kuznetsov : >0.5-W Diode-Pumped VECSEL with circular TEM₀₀ beam, J. Sel. Top. in Quantum Electronics, Vol.5, No 3 May 99



- External cavity : high power + good beam quality
choice of the beam waist - pump radius / high damage threshold
- Design semiconductor structure : diode pumping / choice of the wavelength
- State of the art: 8-W CW VECSEL @ 1000nm (Lutgen et al., APL, Vol.85,N.21, May 2003)
0.5-W CW at 850 nm (Hastie et al., IEEE PTL Vol.15,No7, July 2003)
Single-frequency around 870 nm (Holm et al., IEEE PTL Vol.11,No 2, Dec. 1999)

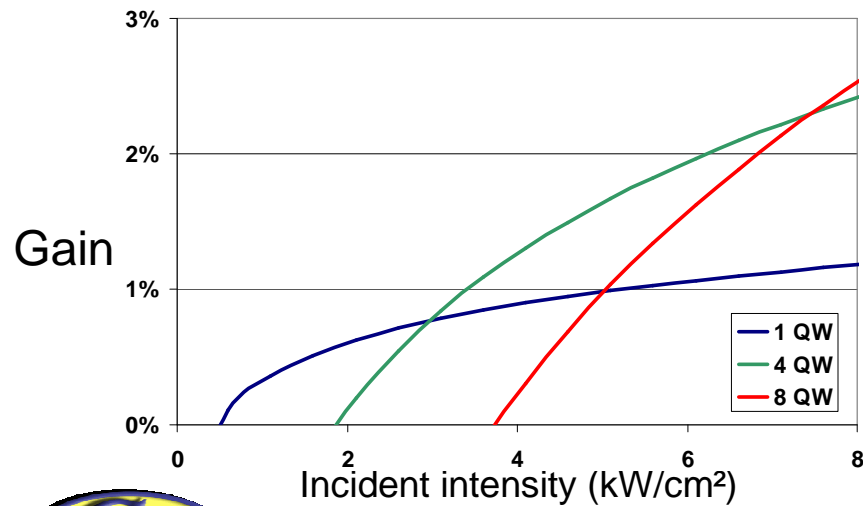
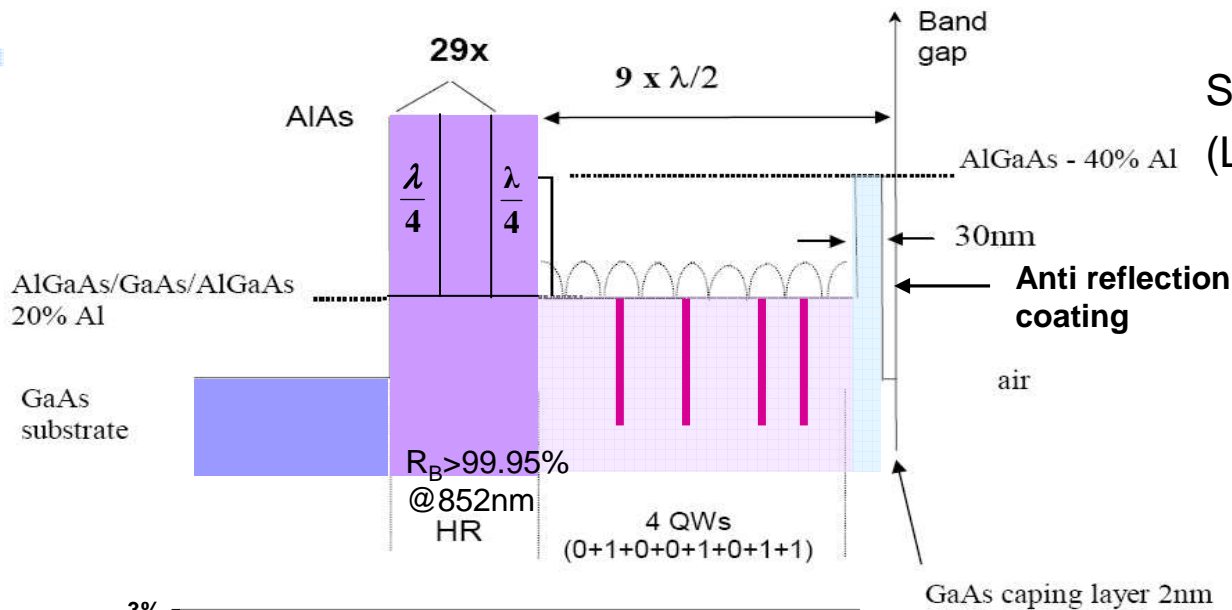
Semiconductor Structure

= Key component of the laser



- Active layers :
 - Absorption in the barriers , gain region : QW
 - Materials : AlGaInP [550 - 700 nm] - AlGaAs [750 - 870 nm] - InGaAsP [0.9 - 1.6 μm]
 - Short absorption depth (few microns) , broad spectral absorption
 - \Rightarrow high power multimode diode pumping
- DBR Mirror : high reflectivity
- Substrate : thermal management

Our Design at 852 nm

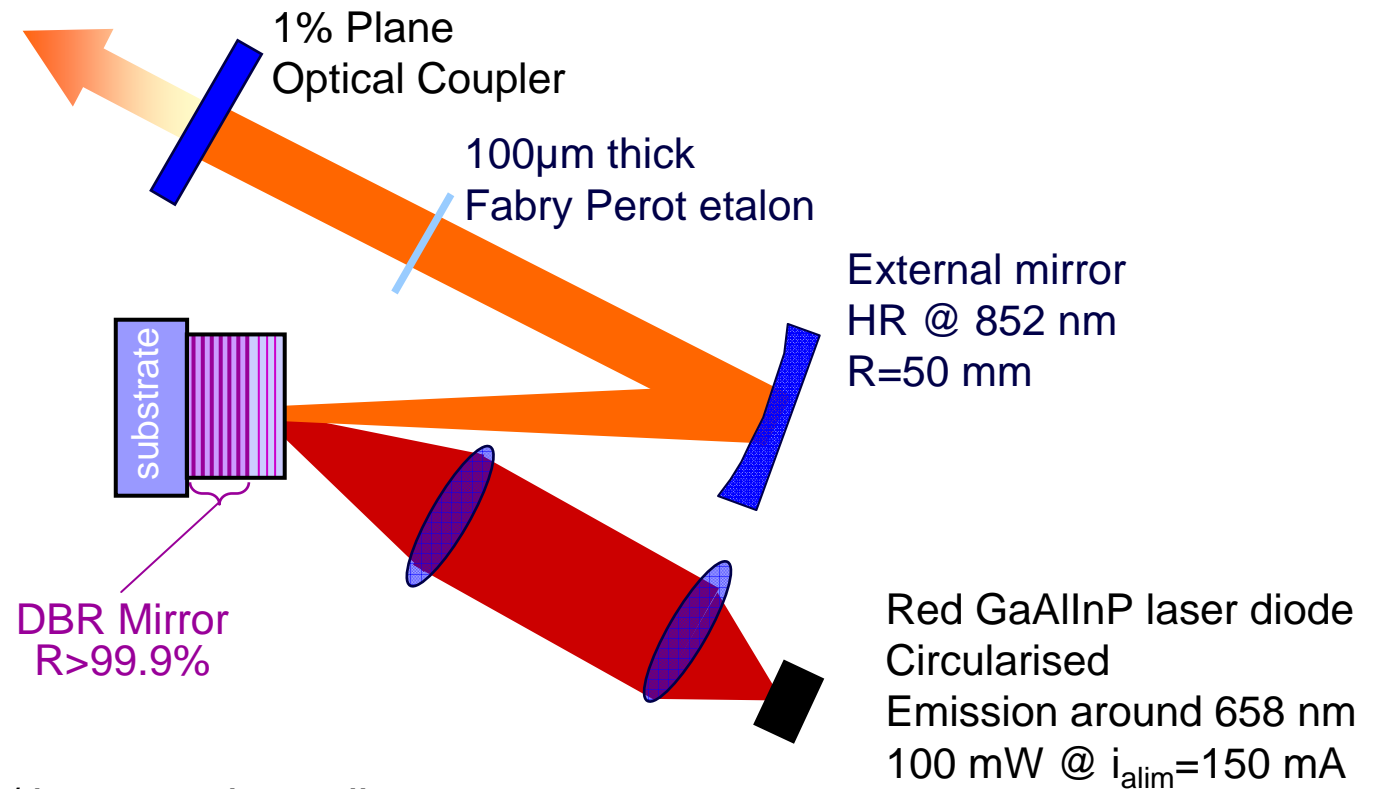


- Optimisation of the number of QW
 - low transparency
 - High gain

$$G(I_{inc}, N_{QW}) = g_0 \ln \left(\frac{I_{inc}}{I_{inc}(n_{tr})} \right) 2L_{QW} N_{QW} \Gamma$$

Experimental setup

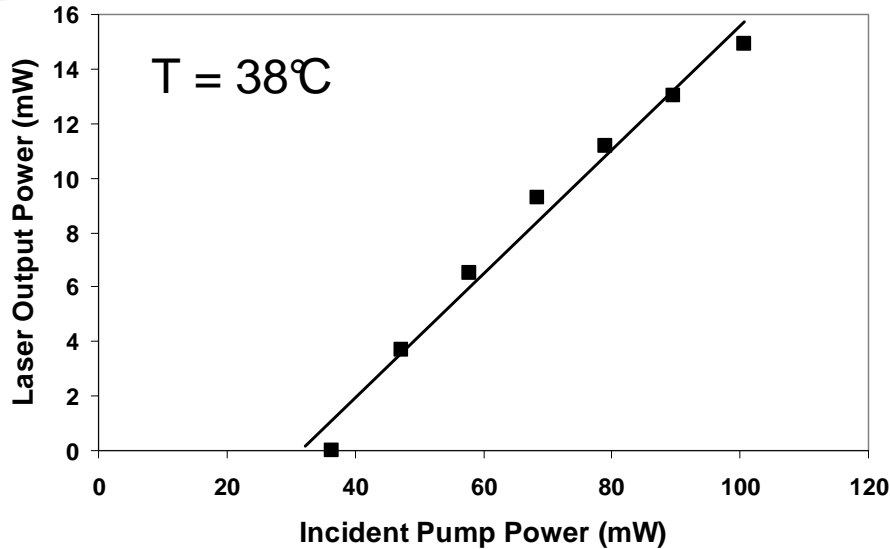
- Three-mirror cavity:



- Pump radius / beam waist radius : $\sim 18 \mu\text{m}$
- Cavity length : ~ 25 cm

Free-running operation

- Performance without any spectral selective element:

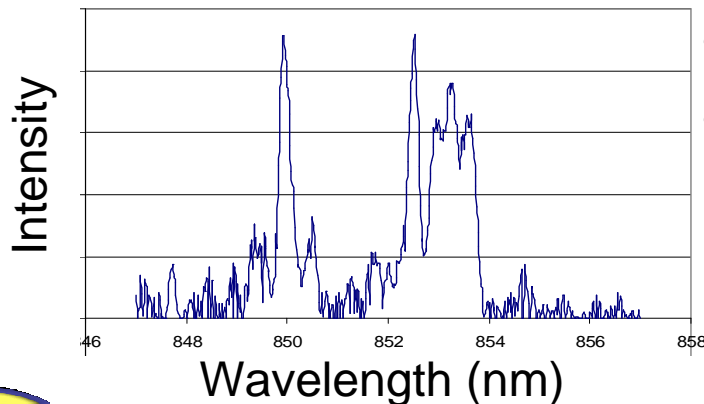


Threshold: 30mW incident pump power
 $\sim I_{th} = 2.9 \text{ kW/cm}^2$
 (theoretically $I_{th} = 2.5 \text{ kW/cm}^2$)

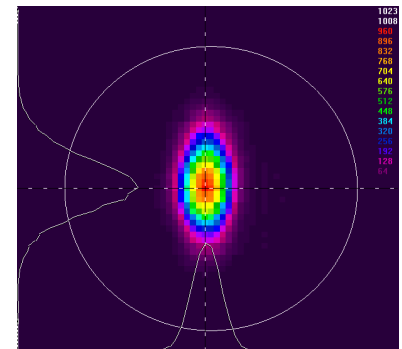
Maximum output power: $P_{max} = 15\text{mW}$
 (100 mW pump power $\longleftrightarrow i_{alim} = 150 \text{ mA}$)

External efficiency: $\eta_{ext} = 23\%$

- Spectrum :

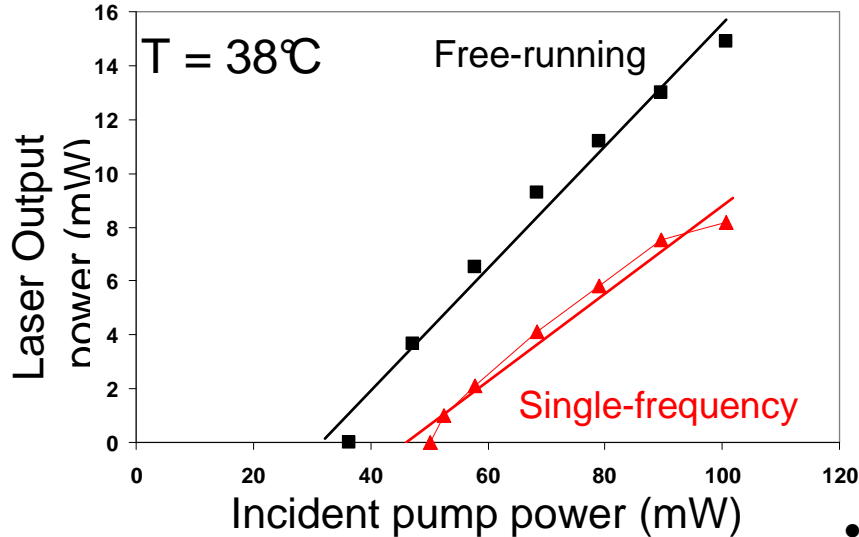


- Broad spectrum $\sim 4 \text{ nm}$
- Good beam quality : $M^2 < 1.2$



Single-frequency emission at 852 nm

- Performance with a 100 μm -thick Fabry Perot etalon intracavity :



Threshold: 50 mW incident pump power

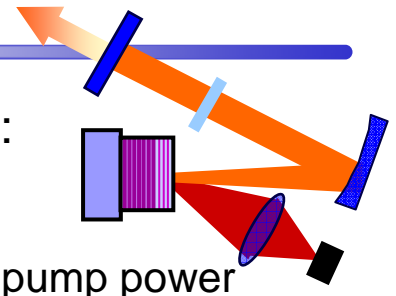
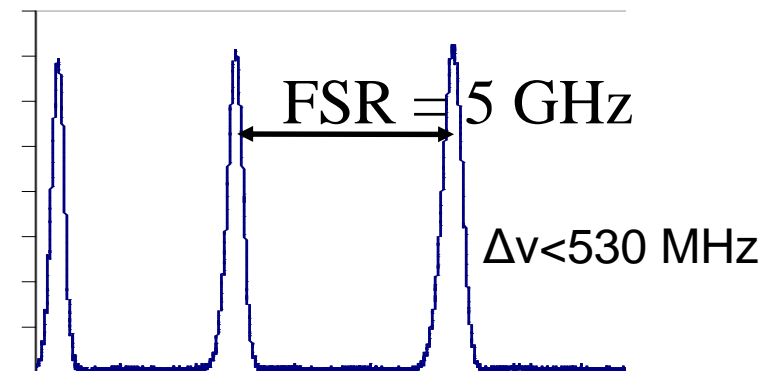
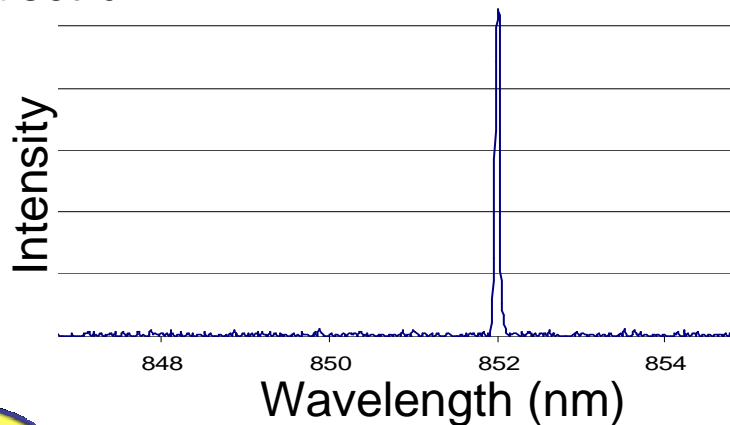
$$\sim I_{th} = 4.9 \text{ kW/cm}^2$$

Maximum output power: $P_{max} = 8.2 \text{ mW}$

(100 mW pump power \longleftrightarrow $i_{alim} = 150 \text{ mA}$)

- External efficiency:** $\eta_{ext} = 16\%$

- Spectrum :



Conclusion & Prospects

- *We achieved :*
 - 15 mW CW free-running operation (100 mW / 150 mA pump current);
 - 8 mW CW @852 nm;
 - single transverse mode and single frequency source.
- **Prospects :**
 - **Development of a monolithic and compact source for evaluation at the SYRTE**
 - **Power scalability**
 - **Thermal management**
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